I he by certify the his correspondence is being deposited with sufficient States Postal Service, with sufficient postage, as first class mail in an envelope addressed to: The Commissioner for Patents, Washington, D.C. 20231, on 411 2002

Date of Deposit

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Our Case No. 10200/103

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
Sadoughi et al.	) ) Group Art Unit: 2812
Serial No. 10/039,469	)
Filing Date: 11/08/2001	)
For: In Situ Deposition of a Nitride Layer and of an Anti-reflective Layer	)

## REQUEST FOR CORRECTION OF FILING RECEIPT

The Commissioner for Patents Washington, D.C. 20231

Attention: Office of Initial Patent Examination's

Customer Service Center

Sir:

Applicants request the issuance of a corrected filing receipt (copy enclosed) for the above-identified application, and in support of this request respectfully state:

U.S. Serial No. 10/039,469

Filed: 11/08/2001 Page Two of Two

In the Title, after "layer and" please insert - - of - -. The title should read "In situ deposition of a nitride layer and of an anti-reflective layer."

The Commissioner is hereby authorized to charge any fees required to Deposit Account No. 23-1925. A duplicate copy of this sheet is enclosed.

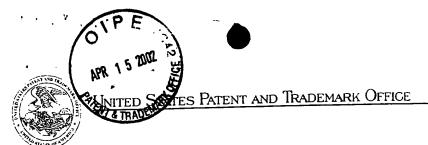
Respectfully submitted,

Dated: 4/11/2002

David Rozenklat

Registration No. 47,044 Attorney for Applicants

BRINKS HOFER GILSON & LIONE P.O. Box 10395 Chicago, Illinois 60610 (312) 321-4200



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APPLICATION NUMBER FILING DATE GRP ART UNIT FIL FEE REC'D ATTY.DOCKET.NO DRAWINGS TOT CLAIMS IND CLAIMS

10/039,469 11/08/2001 11/08/2001 3 23 4

David Rozenblat Brinks Hofer Gilson & Lione P.O. Box 10395 Chicago, IL 60610 CONFIRMATION NO. 1036

MAR 2 7 2002

FILING RECEIPT

\*OC000000007702510\*

Date Mailed: 03/22/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Sharmin Sadoughi, Cupertino, CA; Krishnaswamy Ramkumar, San Jose, CA;

**Assignment For Published Patent Application** 

Cypress Semiconductor Corp.;

Domestic Priority data as claimed by applicant

**Foreign Applications** 

If Required, Foreign Filing License Granted 03/22/2002

Projected Publication Date: Request for Non-Publication Acknowledged

Non-Publication Request: Yes

Early Publication Request: No

Title

In situ deposition of a nitride layer and an anti-reflective layer

**Preliminary Class** 



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